Date Mailed: April 30, 2008 Sheet 1 of 1

FORM 1449* INFORMATION DISCLOSURE STATEMENT	Docket Number: 10873.1944USWO	Application Number: 10/598095	
IN AN APPLICATION	Applicant: KITAOKA, et al.		
(Use several sheets if necessary)	Filing Date: August 17, 2006	Group Art Unit: 1792	

		U.S.	PATENT DOCUME	ENTS		,	
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING IF APPRO	
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		FOREI	GN PATENT DOCU	MENTS			
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
F.H./	2005/121415	December, 2005	WIPO				
F.H./	2008-501600	January, 2008	Japan				
	ОТНЕ	R DOCUMENTS (I	Including Author, Title	, Date, Pertiner	nt Pages, Etc.)		•
	Kawamura Introductio pp. L879-1	on of the Flux Film C	d Phase Epitaxy (LPE) oated-Liquid Phase Ep	) Growth Metho pitaxy (FFC-LP)	od for Growing Large E) Method", Jpn. J. A	e GaN Single Ca Appl. Phys. vol.	rystals: 42 (2003),
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EXAMINER	/Felisa Hiteshew/	DATE CONSIDERED	08/12/2008

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.